

Fig. 1

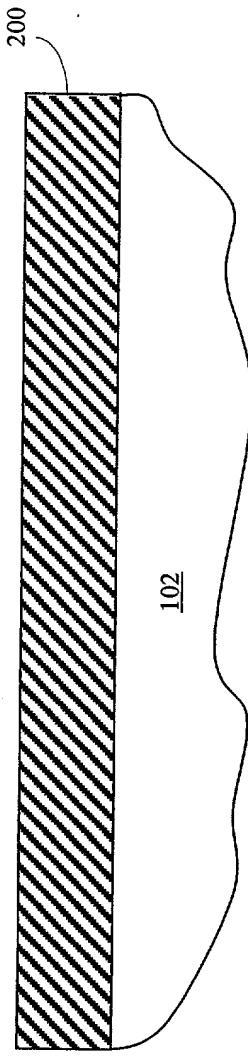


Fig. 2-A

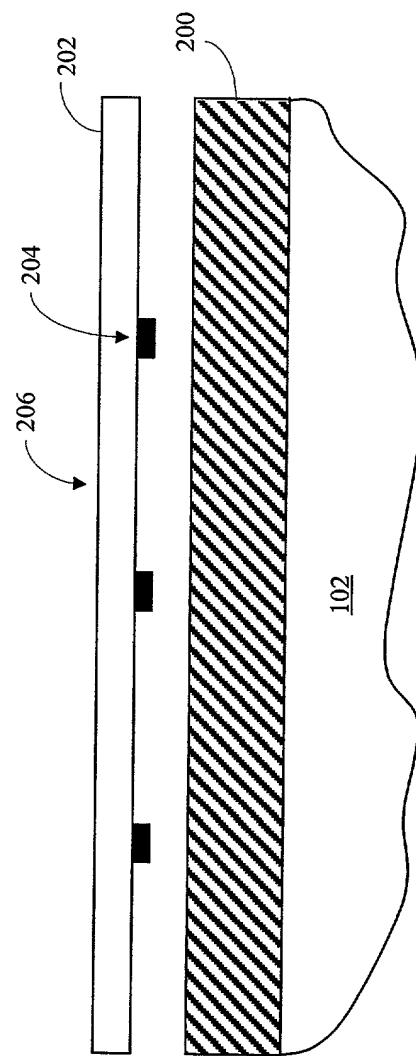


Fig. 2-B

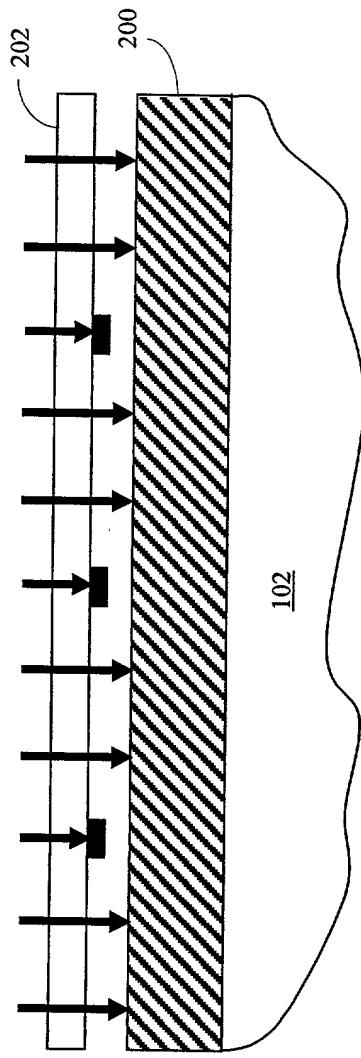


Fig. 2-C

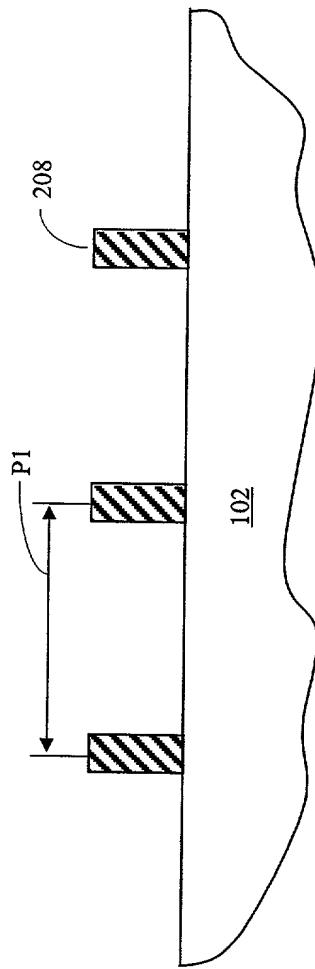


Fig. 2-D

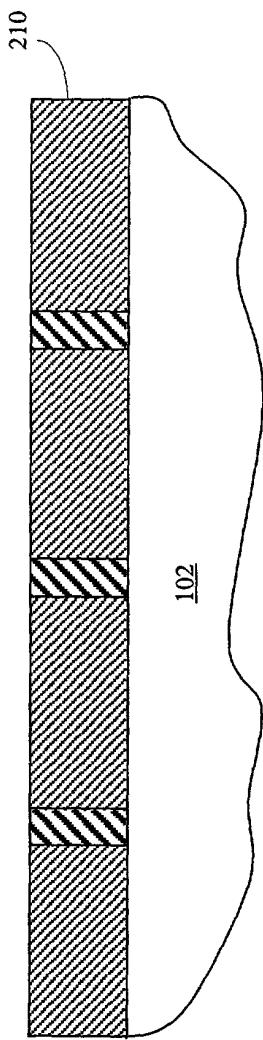


Fig. 2-E

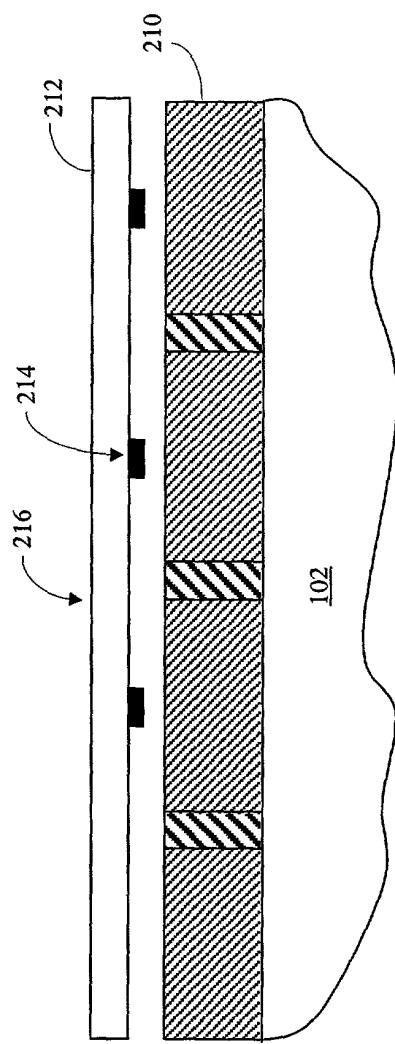


Fig. 2-F

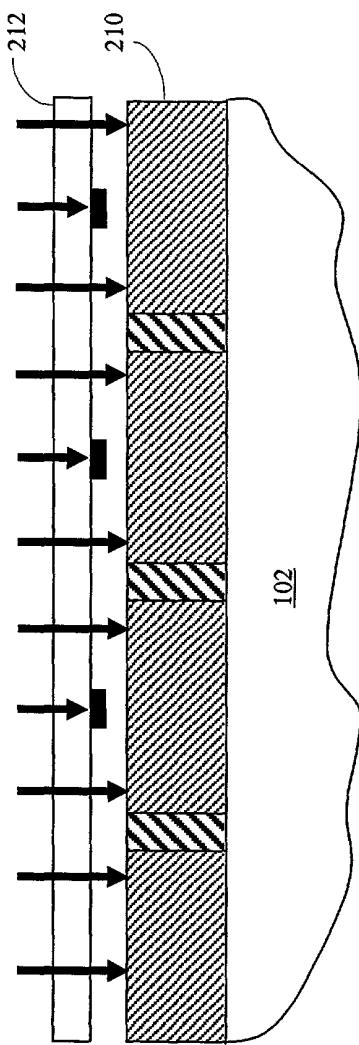


Fig. 2-G

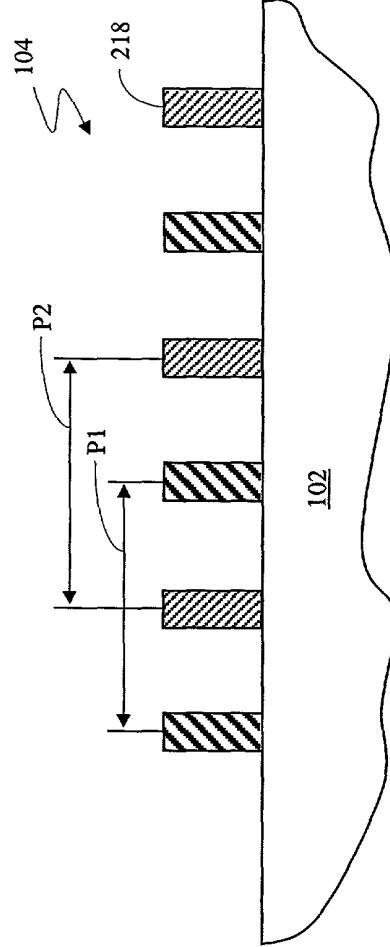


Fig. 2-H

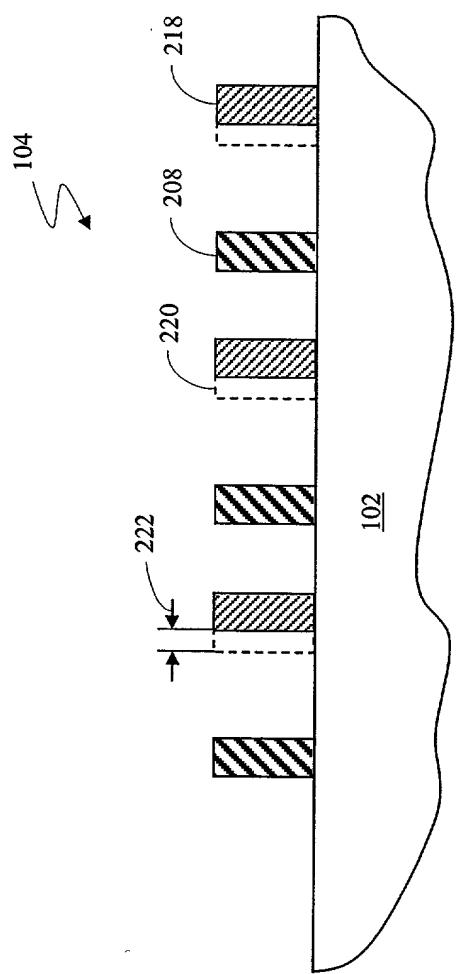


Fig. 2-I

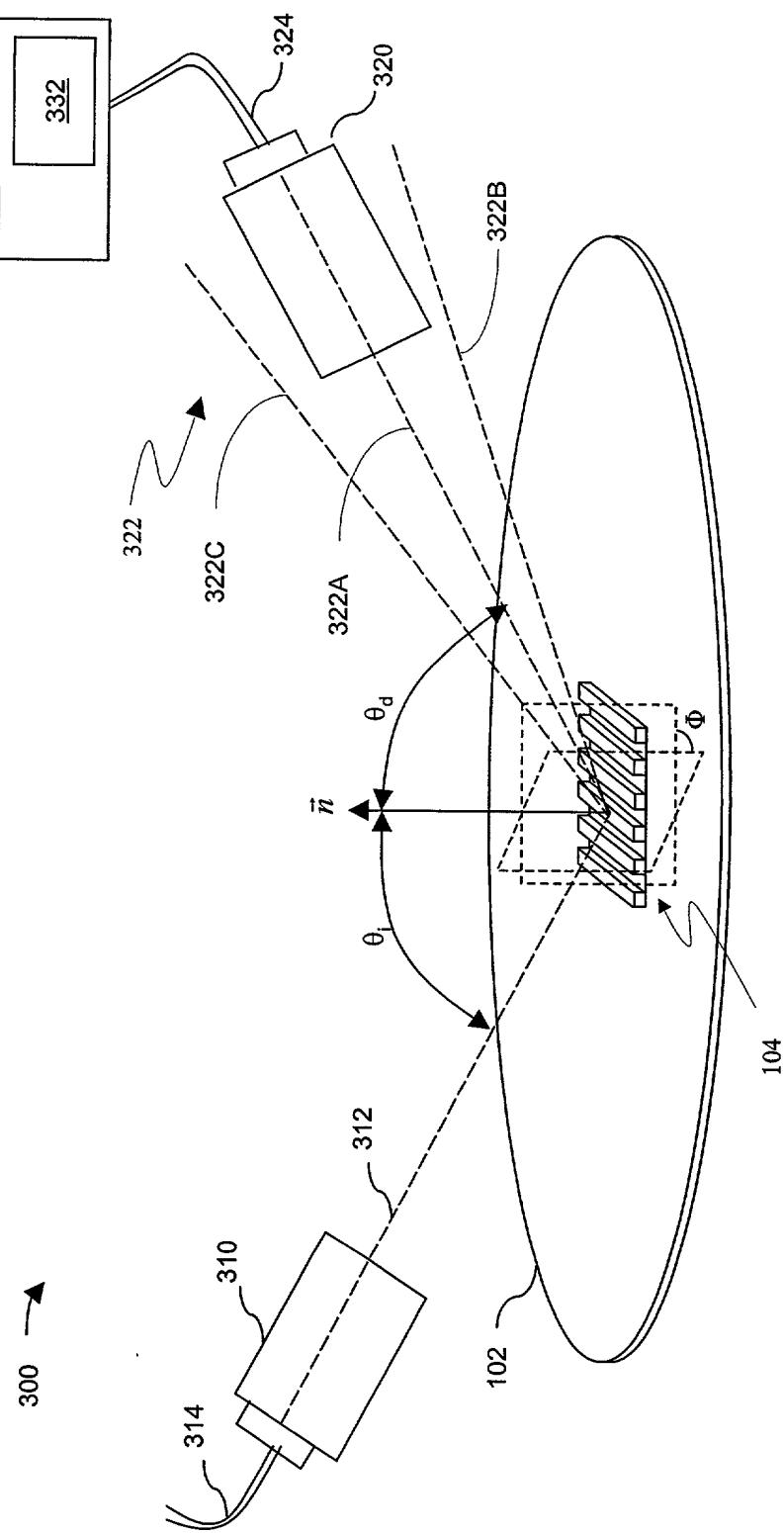


Fig. 3

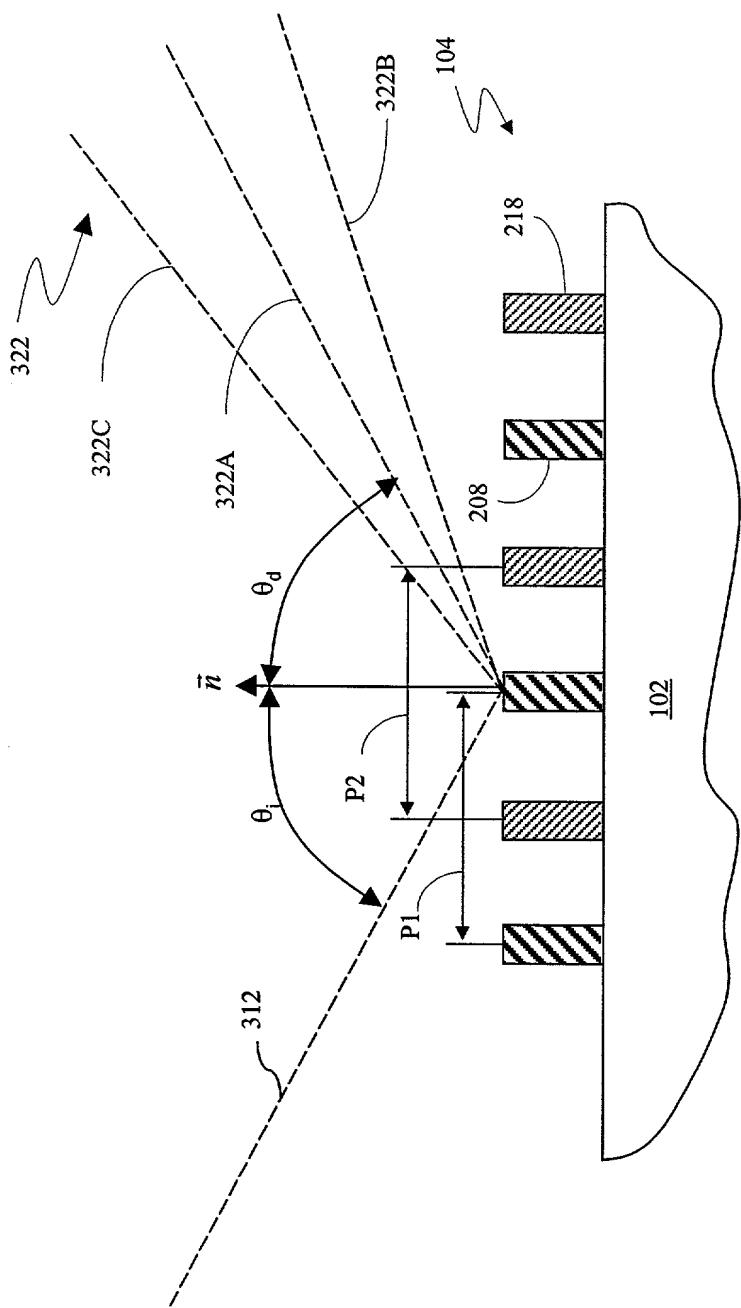


Fig. 4-A

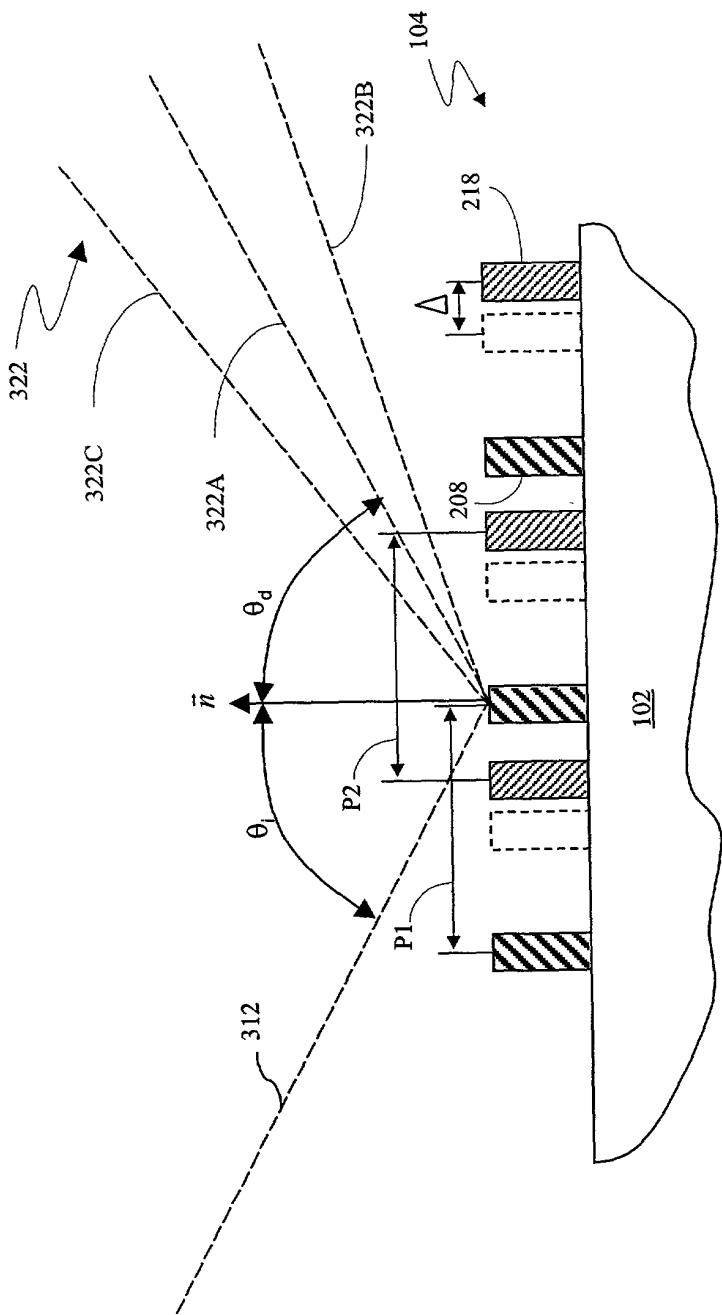


Fig. 4-B

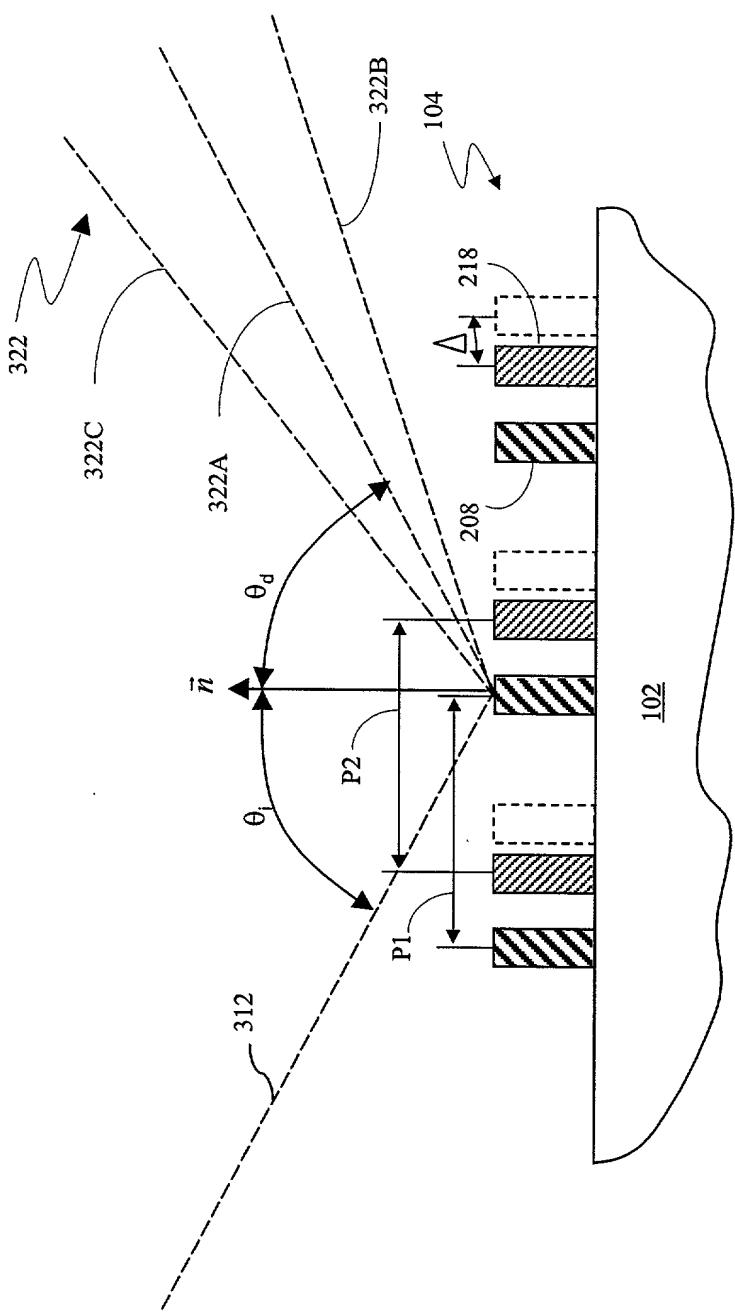


Fig. 4-C

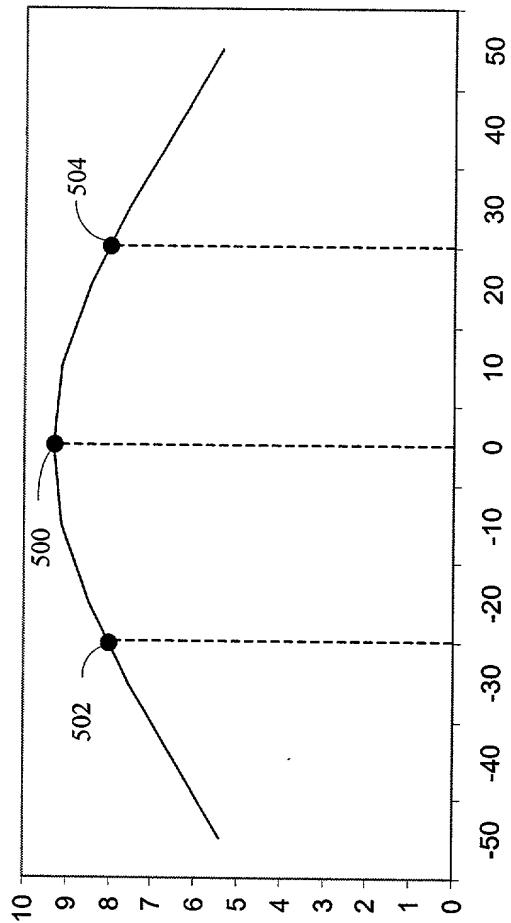


Fig. 5

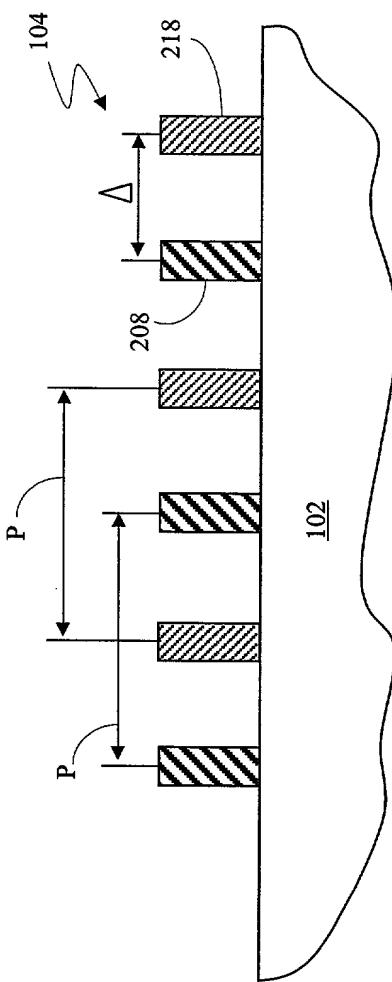


Fig. 6-A

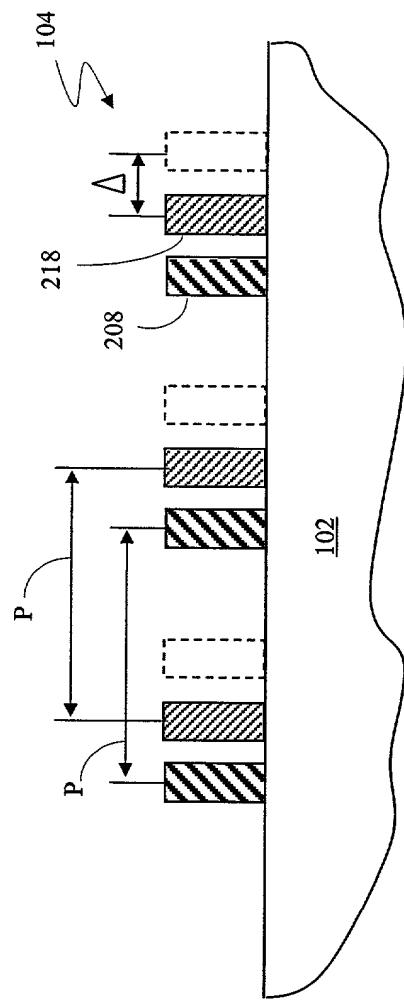


Fig. 6-B

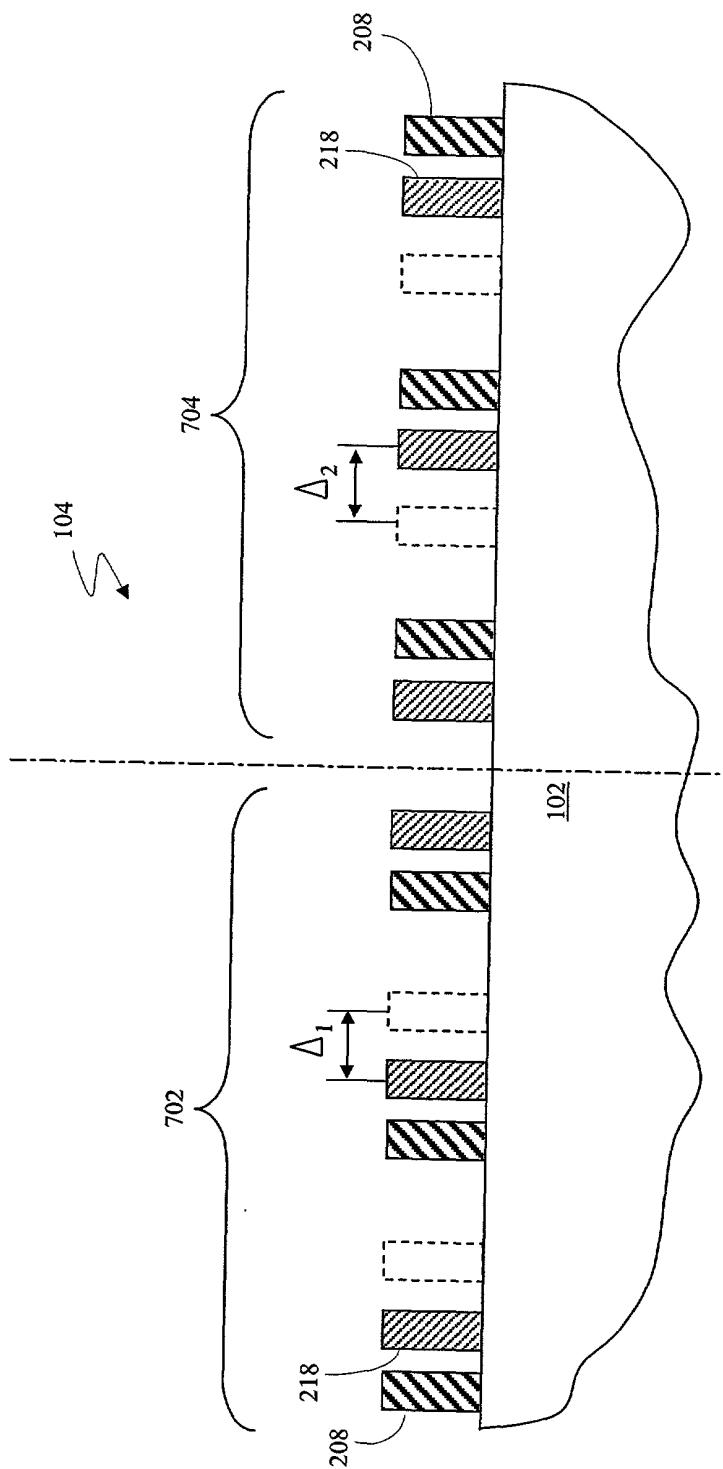


Fig. 7

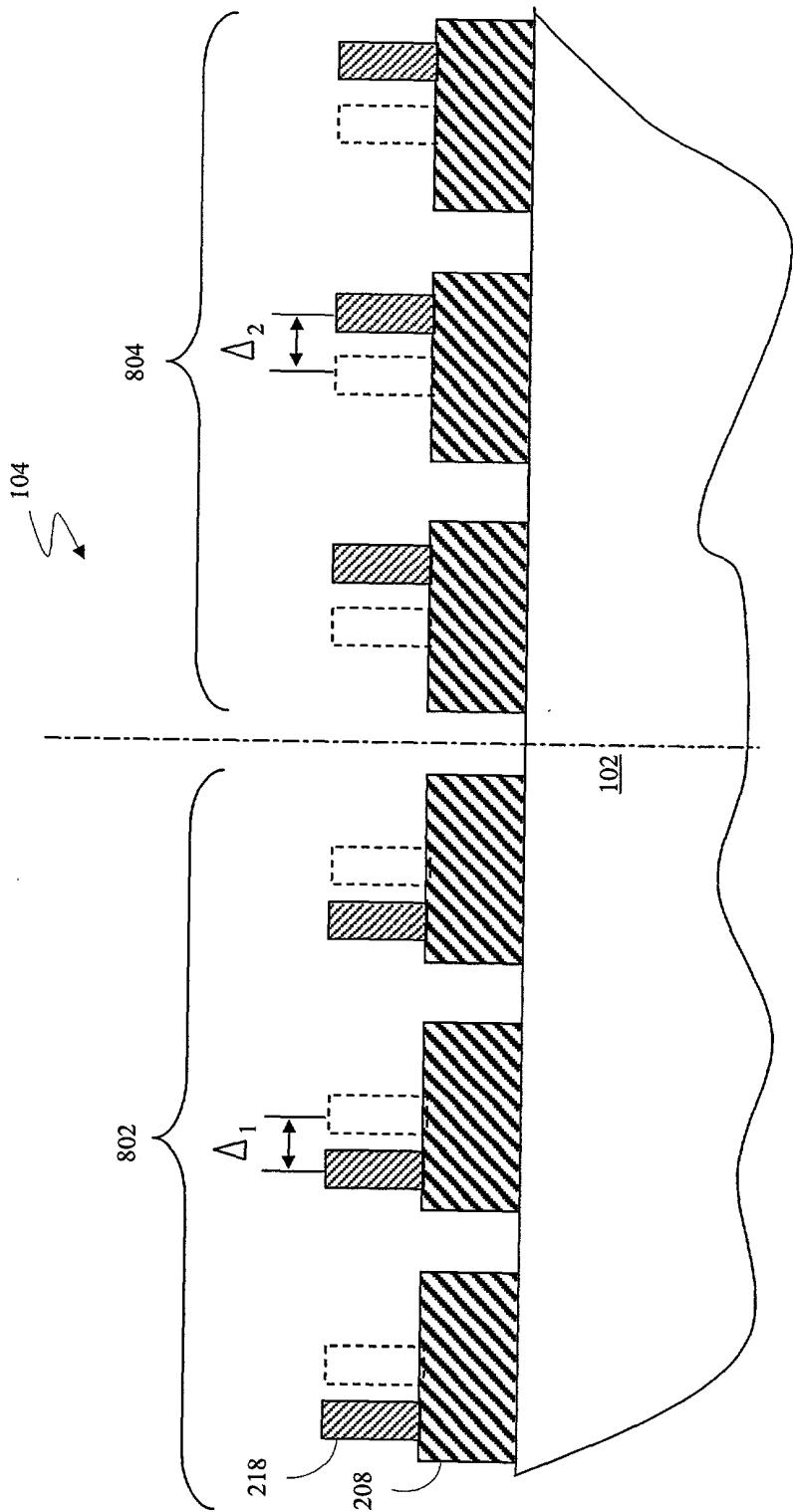


Fig. 8

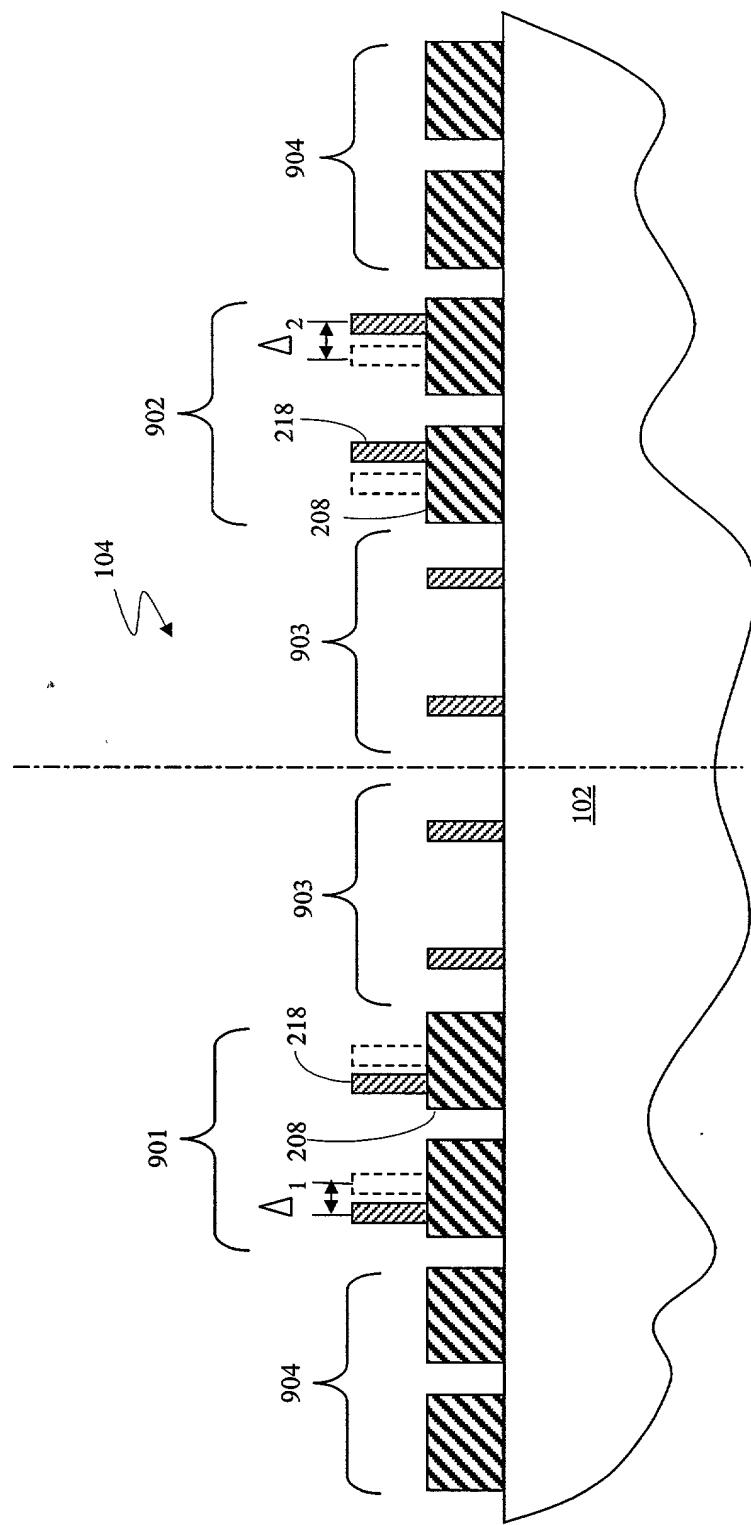


Fig. 9

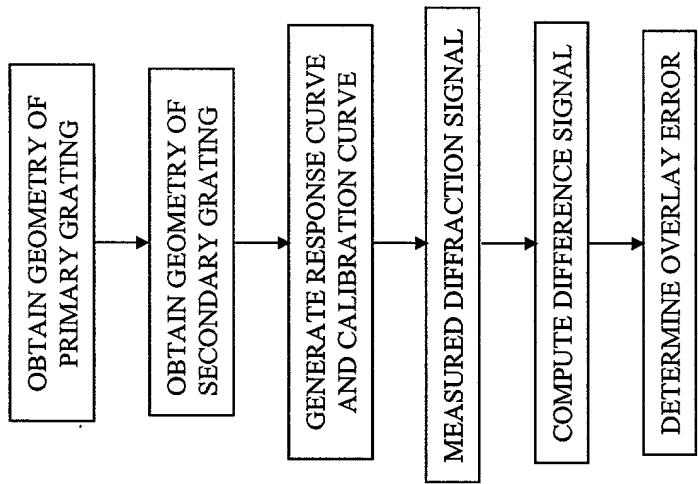


Fig. 10

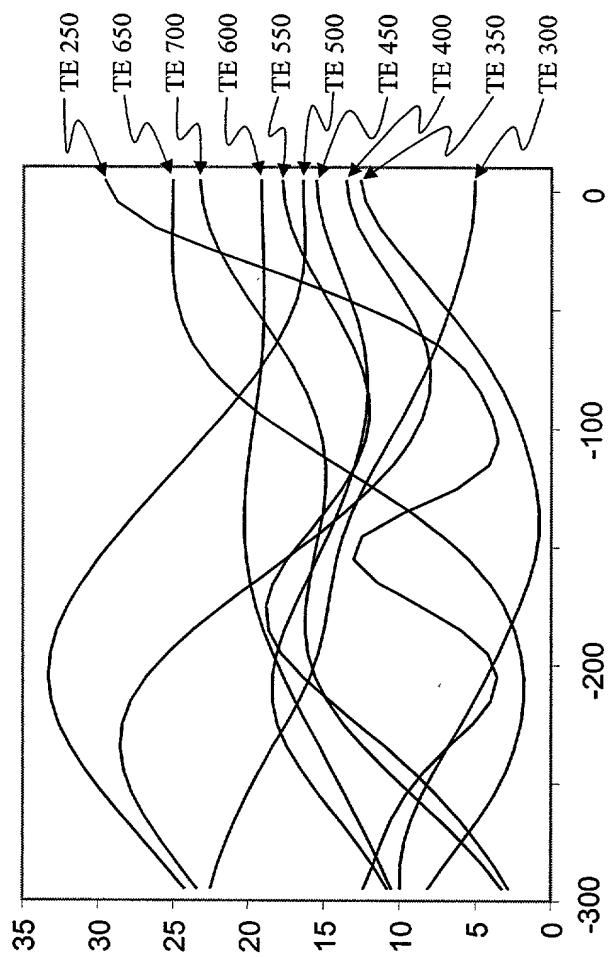


Fig. 11

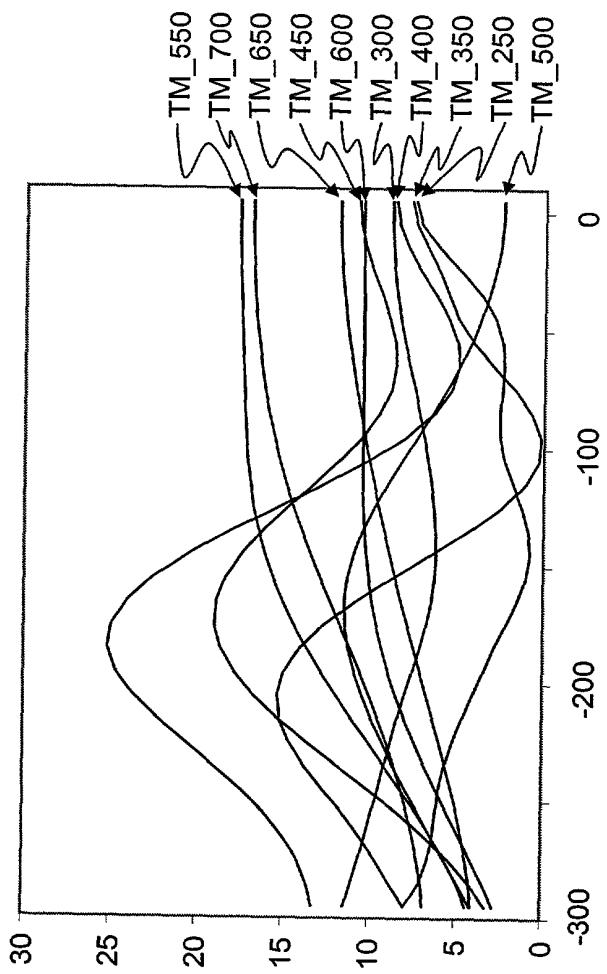


Fig. 12

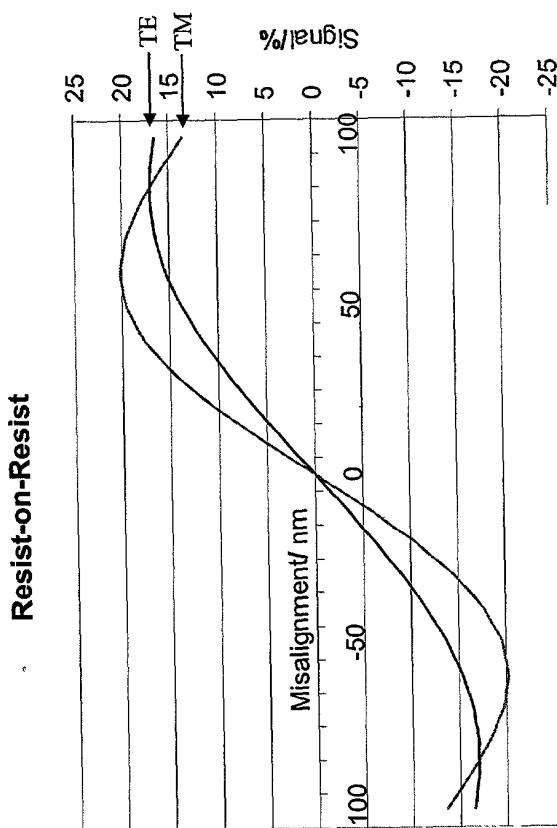


Fig. 13

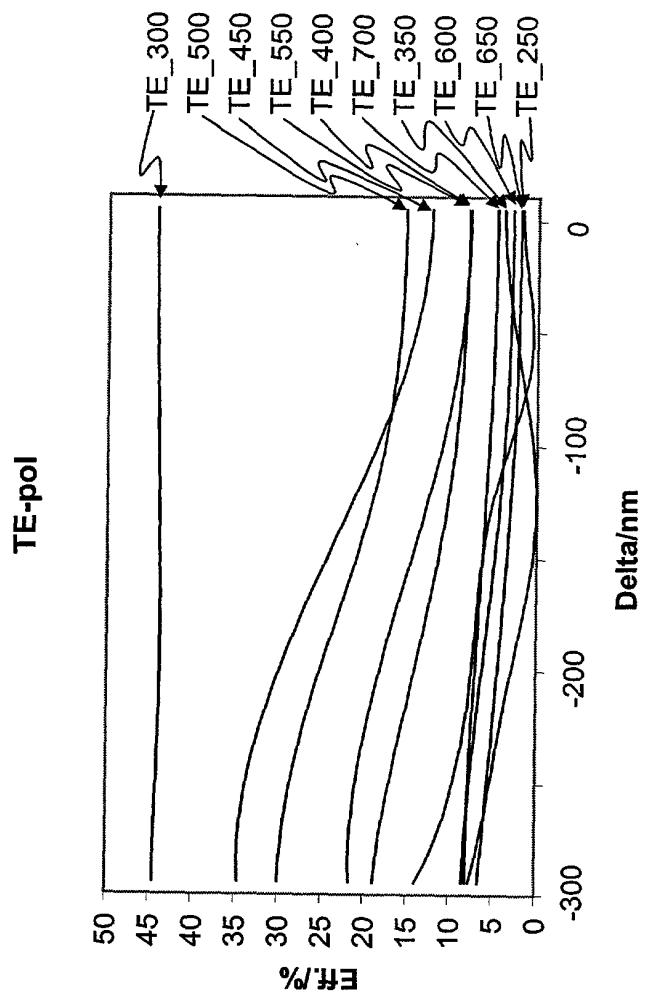


Fig. 14

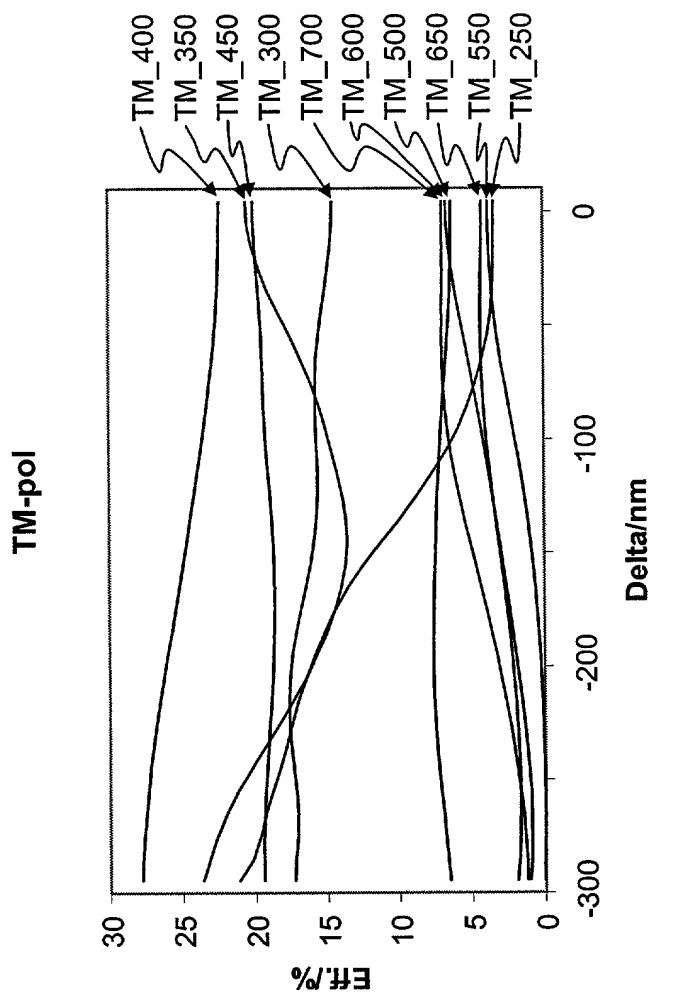


Fig. 15

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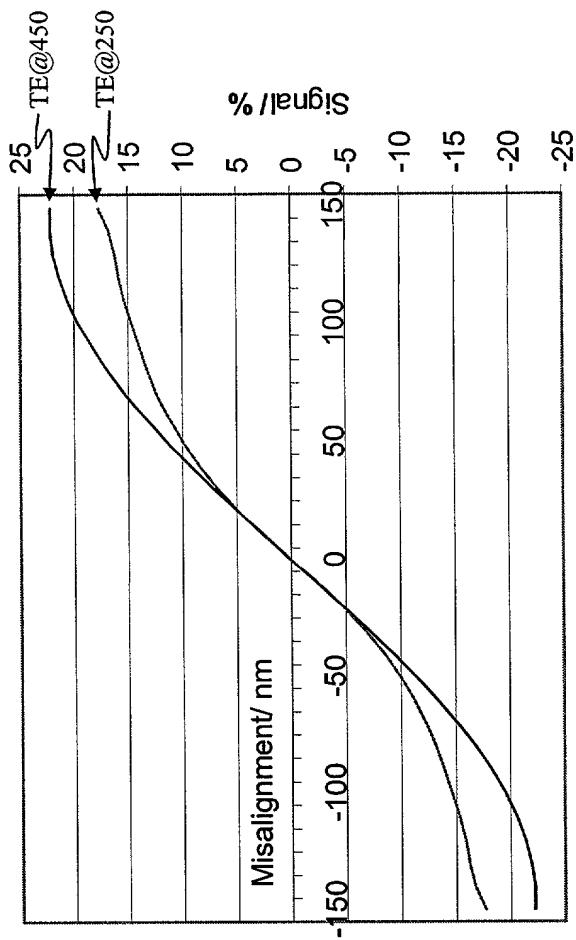


Fig. 16

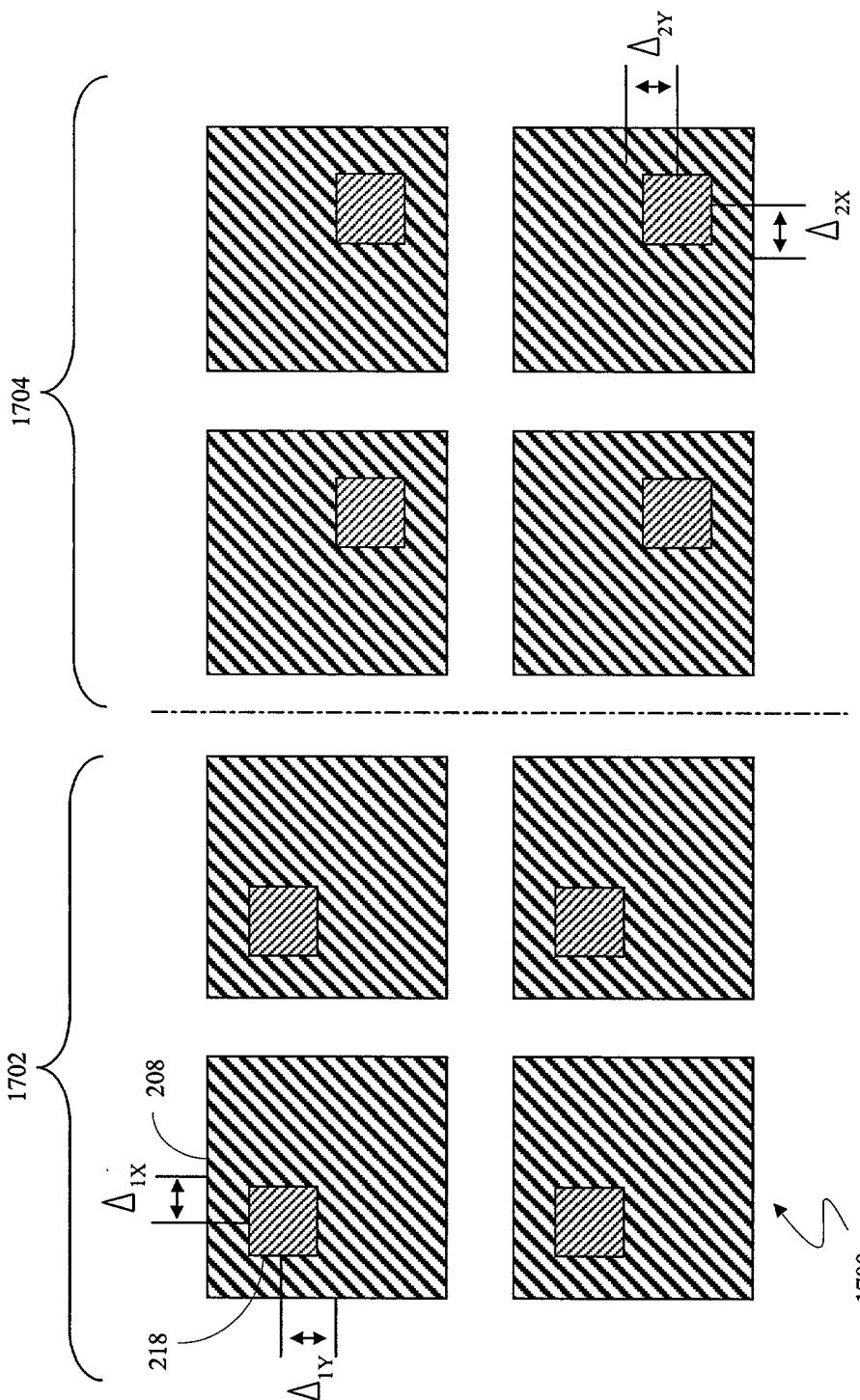


Fig. 17

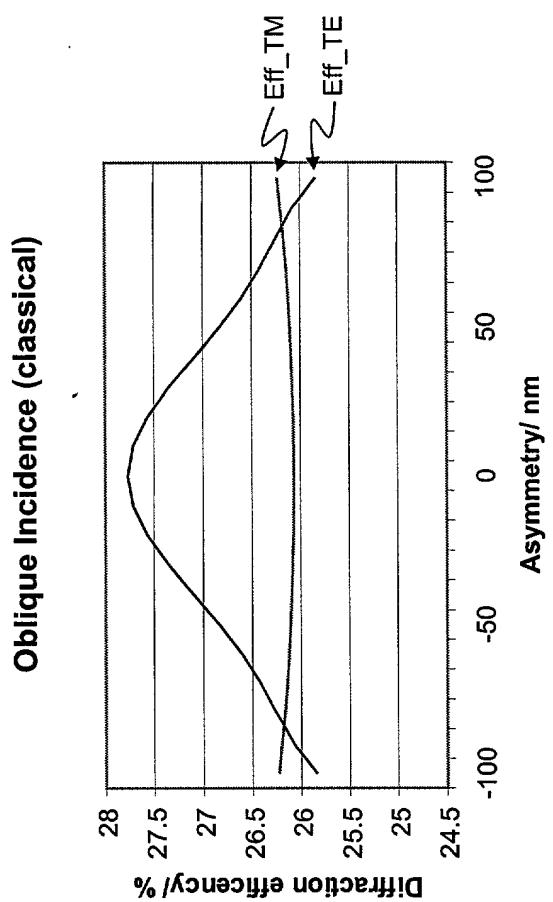


Fig. 18

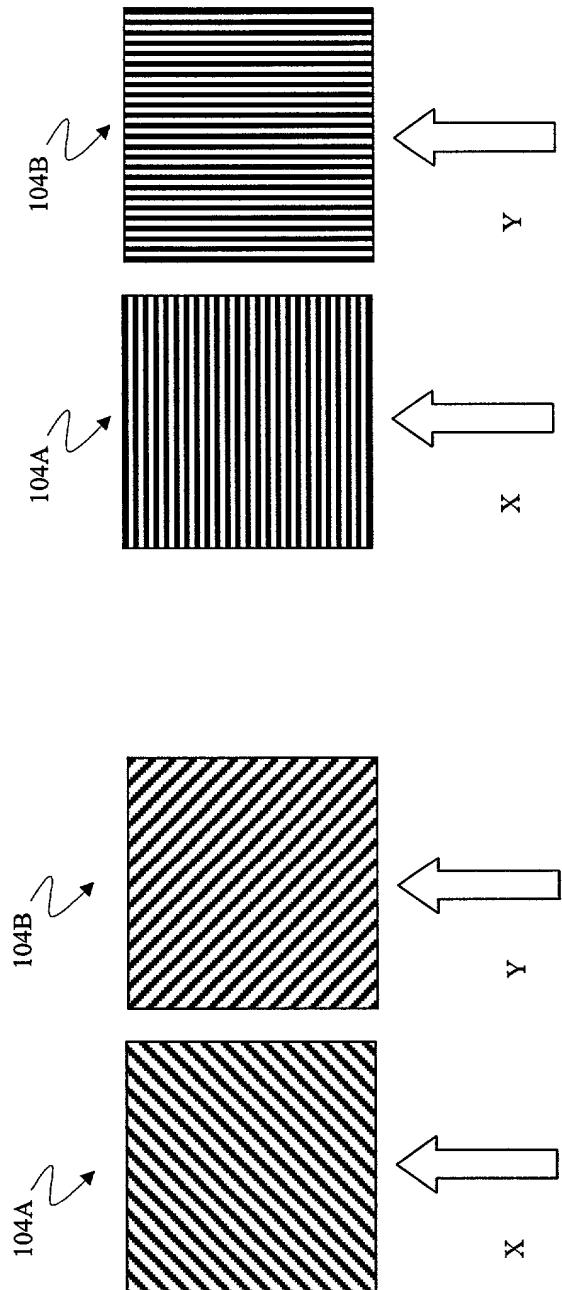


Fig. 19-A
Fig. 19-B

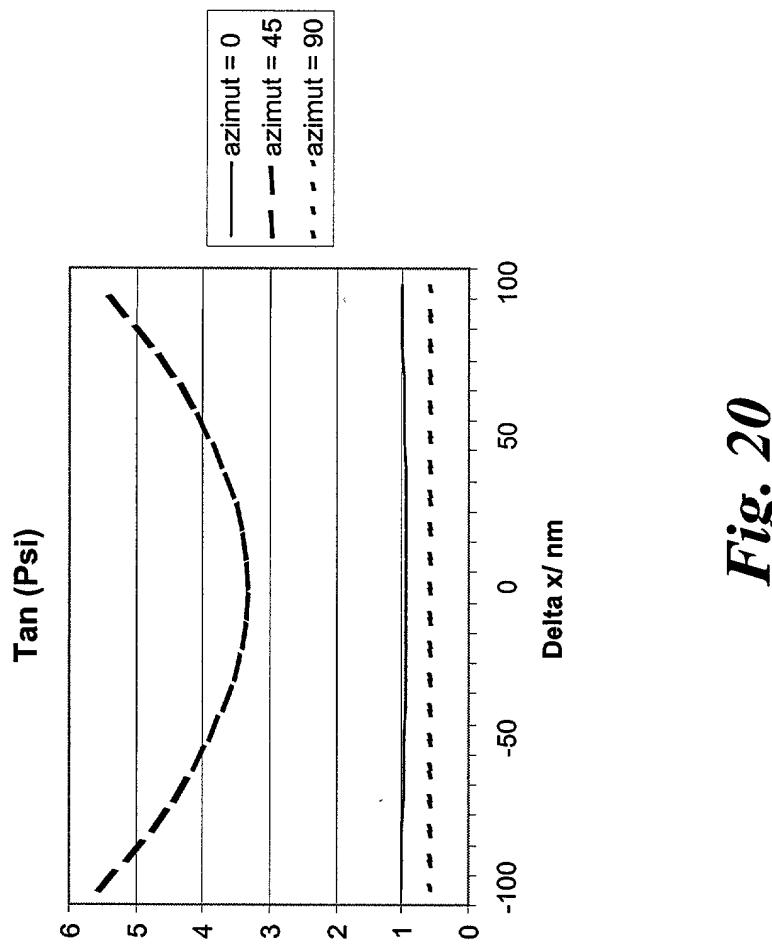


Fig. 20

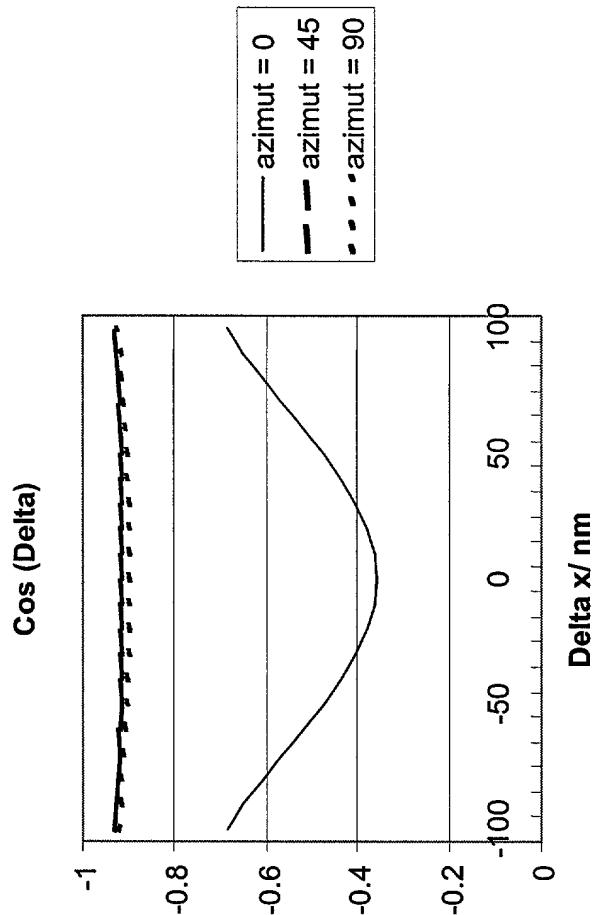


Fig. 21